## Notice of References Cited Application/Control No. 10/565,735 Applicant(s)/Patent Under Reexamination HUMMEL ET AL. Examiner JING OU Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2002/0045909 A1	04-2002	Kimura et al.	606/151
*	В	US-2002/0128667 A1	09-2002	Kobayashi et al.	606/139
*	С	US-6,814,742 B2	11-2004	Kimura et al.	606/151
*	D	US-6,923,818 B2	08-2005	Muramatsu et al.	606/142
*	Е	US-7,011,667 B2	03-2006	Kobayashi et al.	606/142
	F	US-			
	O	US-			
	Ι	US-			
	_	US-			
	٦	US-			
	K	US-			
	┙	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	C					
	V					
	w					
	х					

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.